

10/028429  
10/028429  
11/16/01

708

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10028429	FILING DATE 12/28/2001	CLASS 438	SUBCLASS 197	GAU 2823	EXAMINER K. Nanyan
<b>**APPLICANTS:</b> Hashimoto Koichi, Matsunaga Daisuke, Aoyama Masahiko					
<b>**CONTINUING DATA VERIFIED:</b> THIS APPLICATION IS A DIV OF 08/787 451 01/22/1997					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> JAPAN HEI 5-176956 07/16/1993					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's initials				ATTORNEY DOCKET NO 107317-00039	
TITLE : Dry etching with reduced damage to MOS device					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Assistant Examiner	
<b>ISSUE FEE</b>		Total Claims Print Claim for O.G.	
Amount Due	Date Paid	<b>DRAWING</b> Sheets Drawg. Figs Drawg. Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner	
		Application Examiner	
		<b>PREPARED FOR ISSUE</b>	
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